



Docket No.: 0756-7295 *JFW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE: PATENT application of)
Koichiro TANAKA)
Serial No. 10/827,402) Group Art Unit: 2891
Filed: April 20, 2004) Examiner: Christian Wilson
For: BEAM IRRADIATION APPARATUS, BEAM)
IRRADIATION METHOD, AND METHOD FOR)
MANUFACTURING THIN FILM TRANSISTOR)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
P. O. Box 1450, Alexandria VA 22313-1450, on October 3, 2005

Harry A. Davis

REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789
(571) 434-9499 (Fax)